

VIA EFS
Patent

Docket No. 514312000400
Client Reference No. 04PCT23-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takayuki TOSHIMA et al.

Application No.: 10/579,423

Confirmation No.: 1339

Filed: May 11, 2006

Art Unit: 1792

For: SUBSTRATE PROCESSING METHOD,
SUBSTRATE PROCESSING APPARATUS
AND COMPUTER-READABLE MEMORY
MEDIUM

Examiner: Ryan L. Coleman

RESTRICTION REQUIREMENT RESPONSE

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This is in response to the Restriction Requirement set forth in the Office Action dated September 16, 2009, for which a response is due on October 16, 2009. Accordingly, this response is timely filed.

There are no amendments to the specification, drawings, and claims.

A **Listing of the Claims** begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.